

Search Notes

Application/Control No.

10/817,273

Examiner

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Applicant(s)/Patent under
Reexamination

NISHI, TAKASHI

Art Unit

3729

SEARCHED

Class	Subclass	Date	Examiner
29	606,602.1 846 847	1/9/2006	PK
427	96,97 116		
	123 124		
428	3,42,57 98		
216	2,39,49		
	58,67		
430	313 316		
	317		

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
PGPub Text Search See attachment		5/2/2006	PK

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed Parent Application 09/914542 (US PAT. 6,725,528)	1/6/2006	PK
Text Search EAST/ NPL (IEEE)	1/9/2006	PK
Updated Text Search EAST/ PGPub	5/2/2006	PK